



**ELECTRONIC COPY**

LG811605080  
Report verification at igi.org



June 17, 2026  
IGI Report Number **LG811605080**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **BAGUETTE**  
Measurements **8.66 X 4.26 X 2.71 MM**  
**GRADING RESULTS**  
Carat Weight **1.03 CARAT**  
Color Grade **D**  
Clarity Grade **VS 1**

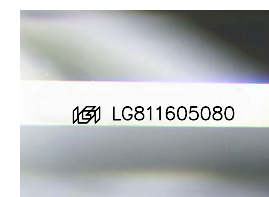
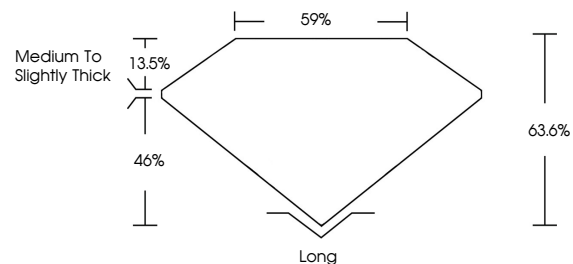
June 17, 2026  
IGI Report Number **LG811605080**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **BAGUETTE**  
Measurements **8.66 X 4.26 X 2.71 MM**

**GRADING RESULTS**  
Carat Weight **1.03 CARAT**  
Color Grade **D**  
Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG811605080**

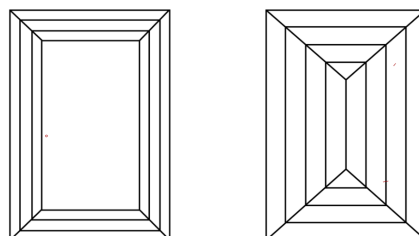
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

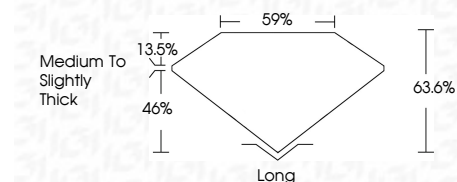
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG811605080**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa



June 17, 2026  
IGI Report No LG811605080  
**BAGUETTE**  
8.66 X 4.26 X 2.71 MM  
1.03 CARAT  
Color Grade **D**  
Clarity Grade **VS 1**  
Table **59%**  
Depth **46%**  
Girdle **Medium to Slightly Thick**  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG811605080**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa